

Application No. 10/803,994  
Supplemental Amendment to Response Filed May 11, 2006.

IN THE ABSTRACT

Page 27, lines 1-7, delete in their entirety and substitute therefore the following new  
Abstract of the Disclosure on the next page 9 of this paper.

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ABSTRACT OF DISCLOSURE

The present invention presents an improved optical window deposition shield for optical access to a process space in a plasma processing system through a deposition shield, wherein the design and fabrication of the optical window deposition shield advantageously provides an optically clean access to the processing plasma in the process space while sustaining substantially minimal erosion of the optical window deposition shield.